

<b>Notice of References Cited</b>	Application/Control No.	Applicant(s)/Patent Under Reexamination	
	10/600,050	MANKOS ET AL.	
	Examiner	Art Unit	Page 1 of 1
Zia R. Hashmi	2881		

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-6,710,342	03-2004	Jau et al.	250/311
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Suzuki et al., "Workpiece Holder, Semiconductor Fabricating Apparatus, Semiconductor Inspection Apparatus....", Pub. No: US 2003/0155508 A1, pub. date: August 21, 2003.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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